



Application No. 10/813,439  
SEC.1140  
AMENDMENT  
May 30, 2006

*IN THE UNITED STATES PATENT AND TRADEMARK OFFICE*

In re Patent application of

:

Sung-Sok Choi

:

Group Art Unit 1763

Serial No. 10/813,439

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Examiner Zervigon, Rudy

Filed March 31, 2004

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Title: APPARATUS AND SYSTEM FOR, AND METHOD OF SUPPLYING PROCESS GAS IN SEMICONDUCTOR DEVICE MANUFACTURING EQUIPMENT

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**AMENDMENT**

U.S. Patent and Trademark Office

**Customer Window, Mail Stop Amendment**

Randolph Building

401 Dulany Street

Alexandria, VA 22314

Sir:

In response to the Office Action dated November 30, 2006, the period for response having been extended by a Petition for Extension of Time attached herewith, the following amendments and remarks are submitted:

**Amendments to the Claims** are reflected in the Listing of Claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.